Lecture 10: Bulk Micromachining II

- Announcements:
  - HW#3: Due Tuesday, 3/5 at 9 a.m.

- Today:
  - Reading: Senturia Chpt. 3, Jaeger Chpt. 11.
  - Handouts: “Bulk Micromachining of Silicon”
  - Lecture Topics:
    - Bulk Micromachining
    - Anisotropic Etching of Silicon
    - Boron-Doped Etch Stop
    - Electrochemical Etch Stop
    - Isotropic Etching of Silicon
    - Deep Reactive Ion Etching (DRIE)

- Last Time:
  - Just starting into Module 6
  - Now, continue with this